



PATENT  
81206-243306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
KALAS et al.

Serial No: 09/880,190

Filed: June 12, 2001

For: THIN RADIATION SOURCE AND  
METHOD OF MAKING THE SAME

Art Unit: 2881  
Examiner: GURZO, PAUL M.

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Mark R. Kendrick 9/11/2003

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AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action dated June 18, 2003 in connection with the  
above-identified application, please enter and consider the following amendment and  
remarks.

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